

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3958	((451/5) or (451/24) or (451/288) or (451/398)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 09:33
L3	73	L1 and electrostatic	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 09:34
S1	425	(279/128).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/26 15:58
S2	852	((361/233) or (361/234)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 07:33
S5	6036	((118/500) or (118/728) or (118/729) or (118/730)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/26 15:57
S6	6036	((118/500) or (118/728) or (118/729) or (118/730)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/27 10:11
S7	270	S6 and (electrostatic adj chuck)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/27 10:11
S8	852	((361/233) or (361/234)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/27 15:09
S9	447	S8 and (electrostatic adj chuck)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/27 15:09
S10	6719	electrostatic adj chuck	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 07:34
S11	3284	S10 and (pin\$1 or protrusion or pusher or (ejector adj pins) or contact)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 07:35
S12	1440	S11 and flat\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 07:35

S13	121	S12 and interferometer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 07:38
S14	45	S13 and adjustable	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/04/29 09:32

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	28	((Computer adj1 Numerical adj1 controlled) or CNC) with (semiconductor or wafer))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:13
L2	9	1 and electrostatic	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:13
L3	7720	((Computer adj1 Numerical adj1 controlled) or CNC)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:13
L4	485	3 and (semiconductor or wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:41
L5	73	4 and electrostatic	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:15
L6	4	4 and (electrostatic adj1 (chuck or holder))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:22
L7	3	4 and (height adj3 (adjust\$4))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:20
L8	17	4 and (height with (adjust\$4))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:20
L9	5035	(electrostatic adj1 (chuck or holder))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:27
L10	20	9 and (Height with adjustment)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:27
L11	6838	(vacuum adj1 (chuck or holder))	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:27
L12	106	11 and (Height with adjustment)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:46

L13	13	3 and vaccum	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:41
L14	978514	(semiconductor or wafer)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 09:01
L15	1175810	14 vaccum or electrostatic	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:43
L16	1937976	14 (vacuum or electrostatic)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:43
L17	150824	14 and (vacuum or electrostatic)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:43
L18	845	17 and (Height with adjustment\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:47
L19	272	18 and (pin or protrusion or pusher)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 08:47
L20	316281	14and conveyor	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 09:01
L21	8021	14 and conveyor	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 09:01
L22	2	14 and (abrad\$3 with conveyor)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/04/29 09:01